

PATENT

IN THE UNITED STATES PATENT OFFICE

In Re	Patent Application of:)		
	· .)	Examiner:	Hoa Q. Pham
	Scott A. Chalmers)	Art Unit:	2877
		.)		
Application No. 09/899,383)		
)		
Filed:	July 3, 2001)		
)		
For:	METHOD AND APPARATUS FOR)		
	HIGH-SPEED THICKNESS MAPPING OF)		
	PATTERNED THIN FILMS)		

Mail Stop Issue Fee Commissioner for Patents PO Box 1450 Alexandria, VA 22313-1450

Amendment After Allowance Under 37 CFR § 1.312(a)

Sir:

This amendment is submitted in accordance with 37 CFR §1.312(a). Please amend the application as follows.